



IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE

In re Patent Application of:

**Inventor:** Chen et al      **Confirmation No:** 8388  
**Serial No.:** 10/769,385      **Examiner:** Pamela Schwartz  
**Filed:** Jan 30, 2004      **Group Art Unit:** 1774  
**Title:** Surface Modification Of Silica In An Aqueous Environment

Commissioner for Patents  
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**RESPONSE TO RESTRICTION REQUIREMENT**

In response to your Office Action/Restriction Requirement dated November 25, 2005; Applicants affirm the election with traverse of Group I (Claims 1-22). Group II (Claims 23-28) and Group III (Claims 29-37) are hereby withdrawn.

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Respectfully submitted,

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I hereby certify that this correspondence is being deposited on the date indicated below with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, PO Box 1450, Alexandria, VA 22313.

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Signature

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